

409508-2026 - Competition

Netherlands – Laboratory, optical and precision equipments (excl. glasses) – European Tender
Electron Beam Lithography system
OJ S 113/2026 15/06/2026
Contract or concession notice – standard regime
Supplies

1. Buyer

1.1. Buyer

Official name: Universiteit Twente
Email: c.delfgaauw@utwente.nl
Legal type of the buyer: Public undertaking
Activity of the contracting authority: Education

2. Procedure

2.1. Procedure

Title: European Tender Electron Beam Lithography system
Description: The University of Twente is tendering to purchase an Electron Beam Lithography system. The MESA+ Institute of the University of Twente will invest in a new Electron Beam system (e-beam system). A system, suitable for defining patterns in electron sensitive resists, at high resolution and high speed, compatible with a wide range of applications and substrate types up to 200mm in diameter. The system will be used by a wide range of users, i.e. academic researchers and students as well as industrial engineers with different backgrounds (photonics, (nano)-electronics etc.) and different levels of expertise.
Procedure identifier: d75e7f85-f950-4008-ab95-b4ee18bf06fa
Internal identifier: 379fcf7e-45c5-4d48-b8ea-3be831450e85
Type of procedure: Open
The procedure is accelerated: no

2.1.1. Purpose

Main nature of the contract: Supplies
Main classification (cpv): 38000000 Laboratory, optical and precision equipments (excl. glasses)
Additional classification (cpv): 38341100 Electron-beam recorders

2.1.2. Place of performance

Country: Netherlands
Anywhere in the given country
Additional information: Zie documentatie

2.1.3. Value

Estimated value excluding VAT: 3 500 000,00 EUR

2.1.4. General information

Legal basis:
Directive 2014/24/EU

2.1.6. Grounds for exclusion

5. Lot

5.1. Lot: LOT-0000

Title: European Tender Electron Beam Lithography system

Description: The University of Twente is tendering to purchase an Electron Beam Lithography system. The MESA+ Institute of the University of Twente will invest in a new Electron Beam system (e-beam system). A system, suitable for defining patterns in electron sensitive resists, at high resolution and high speed, compatible with a wide range of applications and substrate types up to 200mm in diameter. The system will be used by a wide range of users, i.e. academic researchers and students as well as industrial engineers with different backgrounds (photonics, (nano)-electronics etc.) and different levels of expertise.

Internal identifier: 0b4a476d-7047-4e2b-907c-d85c9f9859e4

5.1.1. Purpose

Main nature of the contract: Supplies

Main classification (cpv): 38000000 Laboratory, optical and precision equipments (excl. glasses)

Additional classification (cpv): 38341100 Electron-beam recorders

5.1.2. Place of performance

Country: Netherlands

Anywhere in the given country

Additional information: Zie documentatie

5.1.3. Estimated duration

Other duration: Unknown

5.1.5. Value

Estimated value excluding VAT: 3 500 000,00 EUR

5.1.6. General information

Reserved participation:

Participation is not reserved.

Procurement Project fully or partially financed with EU Funds.

The procurement is covered by the Government Procurement Agreement (GPA): yes

5.1.9. Selection criteria

Sources of selection criteria: Procurement Document, European Single Procurement Document (ESPD)

5.1.11. Procurement documents

Address of the procurement documents: <https://s2c.mercell.com/today/217278>

5.1.12. Terms of procurement

Terms of submission:

Electronic submission: Allowed

Address for submission: <https://s2c.mercell.com/today/217278>

Languages in which tenders or requests to participate may be submitted: English

Electronic catalogue: Not allowed

Deadline for receipt of tenders: 14/08/2026 10:00:00 (UTC+00:00) Western European Time, GMT

Duration during which the tender must remain valid: 90 Days

Terms of contract:

The execution of the contract must be performed within the framework of sheltered employment programmes: No

Electronic invoicing: Allowed

Electronic ordering will be used: no

Electronic payment will be used: yes

5.1.15. Techniques

Framework agreement:

No framework agreement

Information about the dynamic purchasing system:

No dynamic purchase system

5.1.16. Further information, mediation and review

Review organisation: Rechtbank Overijssel

Information about review deadlines: See descriptive document.

Organisation providing more information on the review procedures: Universiteit Twente

8. Organisations

8.1. ORG-0001

Official name: Universiteit Twente

Registration number: 50130536

Postal address: Drienerlolaan 5

Town: Enschede

Postcode: 7522NB

Country subdivision (NUTS): Twente (NL213)

Country: Netherlands

Contact point: Camilio Delfgaauw

Email: c.delfgaauw@utwente.nl

Telephone: +31534891512

Internet address: <https://www.utwente.nl>

Buyer profile: <https://s2c.mercell.com/buyer/16033>

Roles of this organisation:

Buyer

Organisation providing more information on the review procedures

8.1. ORG-0002

Official name: Rechtbank Overijssel

Registration number: 82940525

Town: Almelo

Postcode: 7607 GB

Country subdivision (NUTS): Twente (NL213)

Country: Netherlands

Email: communicatie.rb-ove@rechtspraak.nl

Telephone: (+31)0883611042

Roles of this organisation:

Review organisation

Notice information

Notice identifier/version: d8072cd8-e497-49af-b432-8865f10c18de - 01

Form type: Competition

Notice type: Contract or concession notice – standard regime

Notice subtype: 16

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